

<b>Notice of References Cited</b>	Application/Control No. 10/789,119	Applicant(s)/Patent Under Reexamination KIM ET AL.	
	Examiner SHANTELL HEIBER	Art Unit 2617	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A US-2003/0066082	04-2003	Kliger et al.	725/80
	B US-			
	C US-			
	D US-			
	E US-			
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**FOREIGN PATENT DOCUMENTS**

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